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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Yasuji HIRAMATSU, et al.

SERIAL NUMBER: 10/070,443

GROUP: 3742

FILED: June 24, 2002

EXAMINER: FUQUA, SHAWNTINA T

FOR: CERAMIC HEATER FOR A SEMICONDUCTOR PRODUCING/EXAMINING
DEVICE, PROCESS OF PRODUCING THE CERAMIC HEATER, AND
PRODUCTION SYSTEM OF THE CERAMIC HEATER

REQUEST TO CORRECT TITLE OF INVENTION

MAIL STOP ISSUE FEE
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application for patent, we hereby request
correction of your records to reflect the correct title of the invention. The title of the
invention should read as follows: **CERAMIC HEATER FOR A SEMICONDUCTOR**
PRODUCING/EXAMINING DEVICE, PROCESS OF PRODUCING THE CERAMIC
HEATER, AND PRODUCTION SYSTEM **OF** THE CERAMIC HEATER.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

A handwritten signature in cursive script, reading "Joseph Scafetta, Jr.", written over a horizontal line.

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